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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/842,022	04/26/2001	Satoshi Tomioka	SON-2077	6904
23353	7590 09/25/2003			
	SHMAN & GRAUER	PLLC	EXAM	INER
	TREET N.W., SUITE 5	VARGOT, MATHIEU D		
WASHINGI	ON, DC 20036		ART UNIT	PAPER NUMBER
			1732	
			DATE MAILED: 09/25/2003	3

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Sum.  —The MAILING DATE of this communication and 842,022  Period for Reply  Period for Reply  Period for Reply	T Group	
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-The MAILING DATE of this case	the corresponde	
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Period for Reply  A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXP. beneator of the major of time may be available under the provisions of 37 CFR 1.136(a). In no event from the mailing date of this communication.  If the period for reply specified above is less than thirty (30) days, a reply within the stature to No period for reply is specified above, such period shall, by default, expire SIX (6) MO.  If NO period for reply is specified above, such period shall, by default, expire SIX (6) MO.  Failure to reply within the set or extended period for reply will, by statute, cause the approximation of the period by the Office later than three months after the mailing date of this content adjustment. See 37 CFR 1.704(b).	notory minimination to the timety filed after Survival NTHS from the tim	
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U.S. Patent and Trademark Office PTO-326 (Rev 11/00) Art Unit: 1732

1. Claims 1-10 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

Claim 1, line 4 contains a reference to "growth substrate" whereas the penultimate line recites "the growth base". Given that what is grown on the base is also called a substrate, it is preferable that applicant use consistent terminology for the base and the substrate grown thereon. In claim 5, line 2, it would appear that "while" should be --with--.

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-4 are rejected under 35 U.S.C. 103(a) as being unpatentable over the article "Relaxation Mechanism of Thermal Stresses in the Heterostructure of GaN Grown on Sapphire by Vapor Phase Epitaxy" to Hiramatsu et al.

The article to Hiramatsu et al discloses the basic claimed process of growing a GaN substrate on a sapphire base layer using hydride vapor phase or metal organic vapor phase epitaxy, with the sapphire base being 250 microns in thickness and the GaN substrate being grown to thicknesses of 1200 microns, as long as the growth layer exceeds the critical thickness of 100 microns so that the strain in the GaN layer is relaxed. Essentially, Hiramatsu et al fails to explicitly disclose using a sapphire base layer which has a thickness of less than 100 microns while the GaN substrate grown

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has a thickness of larger than 200 microns and the exact curvature of substrate. It is submitted that the exact thickness of the sapphire base layer and the exact thickness of the GaN growth layer would have been well within the skill level of the art as long as the thickness of the GaN layer exceeds the critical thickness so that the strain in the growth layer is reduced and same does not suffer from cracks. Note also that the growth layer of 1200 microns would be on the order of 6 times thicker than the base sapphire substrate, so the latter would be much thinner than the layer grown thereon. The exact curvature of the GaN or growth layer would have also been within the skill level of the art. See the article to Hiramatsu et al, page 1528, second paragraph on the left and Figure 4 which shows how the curvature of the grown GaN film varies with layer thickness.

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- 3. Claims 5 and 6 are rejected under 35 U.S.C. 103(a) as being unpatentable over the article to Hiramatsu et al in view of Chen et al (see col. 1, line 65; col. 2, lines 19-20).
- The primary reference discloses the basic claimed process lacking essentially a disclosure of using doping impurities. Chen et al discloses these and such would have been an obvious modification to the process of Hiramatsu et al so that the grown layer is sufficiently flexible to facilitate removal from the base substrate. Chen also teaches that the growth base should be very thin--see col. 2, lines 19-20)
- Claims 7-10 are rejected under 35 U.S.C. 103(a) as being unpatentable over the article to 4. Hiramatsu et al in view of Japanese document 10-256,662.

The article to Hiramatsu et al discloses the basic claimed process lacking essentially a clear disclosure of removing the growth base and flattening the surface of the grown substrate.

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Japanese -662 teaches these aspects and such would have been an obvious addendum to the

process shown in Hiramatsu et al dependent on the final use for the GaN film. Ie, while the article

performs research, one of ordinary skill in making an actual product would have found the

removal of the base and the polishing/flattening of the conductor (GaN) surface as obvious to

make a final semiconductor substrate. Protection films would likewise have been obvious to

ensure that the surface of the semiconductor layer is not damaged during the base substrate

removal.

5. The prior art made of record and not relied upon is considered pertinent to applicant's

disclosure. Hong et al is cited as of interest in forming GaN film over a growth base.

6. Any inquiry concerning this communication or earlier communications from the examiner

should be directed to M. Vargot whose telephone number is 703 308-2621.

Any inquiry of a general nature or relating to the status of this application or proceeding

should be directed to the receptionist whose telephone number is 703 308-0661.

M. Vargot

September 21, 2003

M. Varget

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